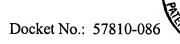
IFW



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Yoshikazu IBARA : Confirmation Number: 6031

Serial No.: 10/768,170 : Group Art Unit: 2825

Filed: February 02, 2004 : Examiner: Caridad Everhart

For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE

AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following Amendment and remarks are submitted in response to the Office Action June 25, 2004.